

IFWV

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of

Docket No: Q67940

Masaki KURIHARA, et al.

Allowed: May 17, 2004

Appln. No.: 10/035,137

Group Art Unit: 1752

Confirmation No.: 3139

Examiner: John Chu

Filed: January 04, 2002

For: POSITIVE PHOTORESIST COMPOSITION

AMENDMENT UNDER 37 C.F.R. §1.312

MAIL STOP ISSUE FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 C.F.R. §1.312, please amend the above-identified application as follows on the accompanying pages.

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